

APPARATUS AND METHOD FOR DETECTING WAFER POSITION

Inventor: CHEN, Jun-Ming et al.

Docket No. 4425-308

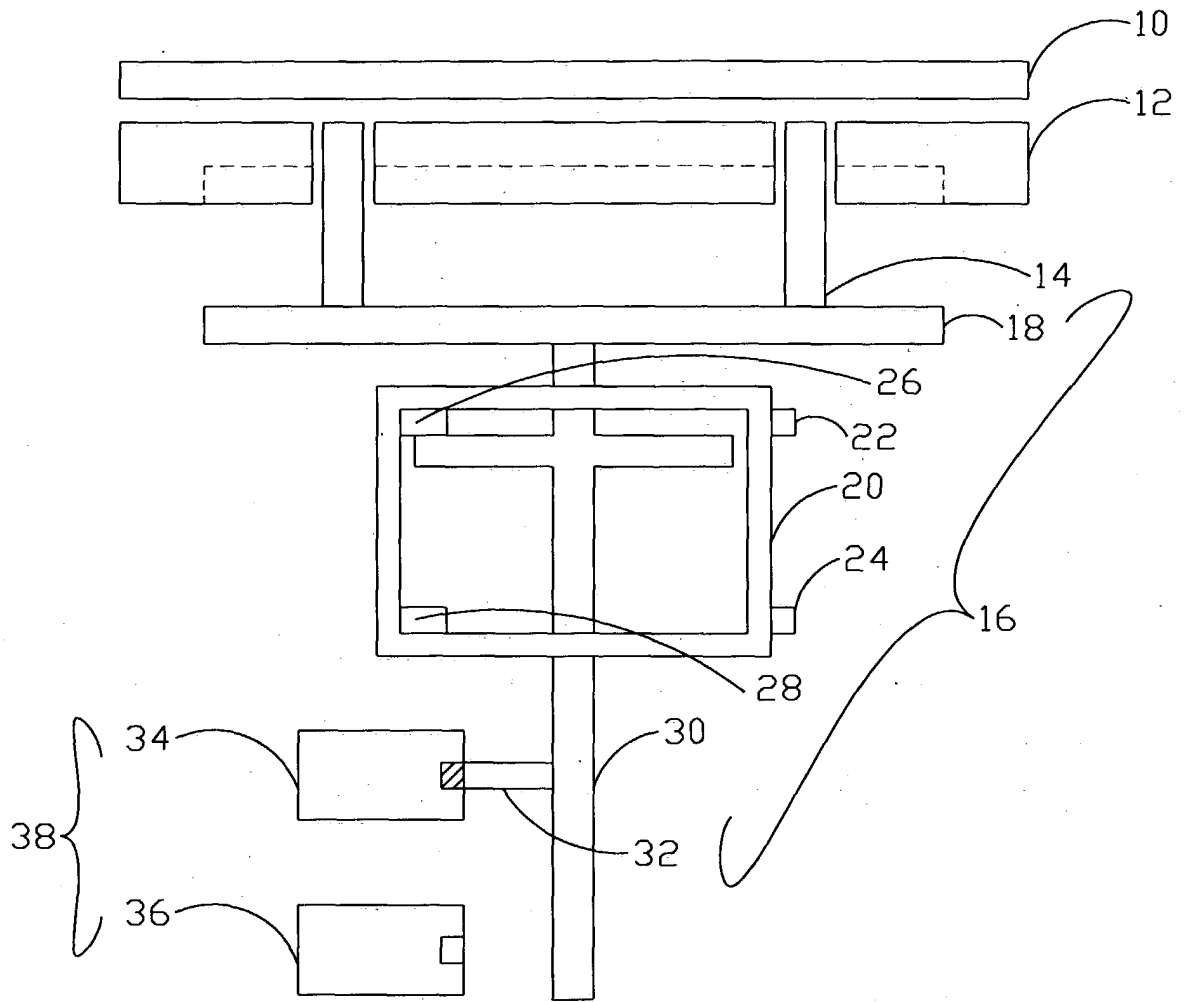


FIG. 1A(Prior Art)

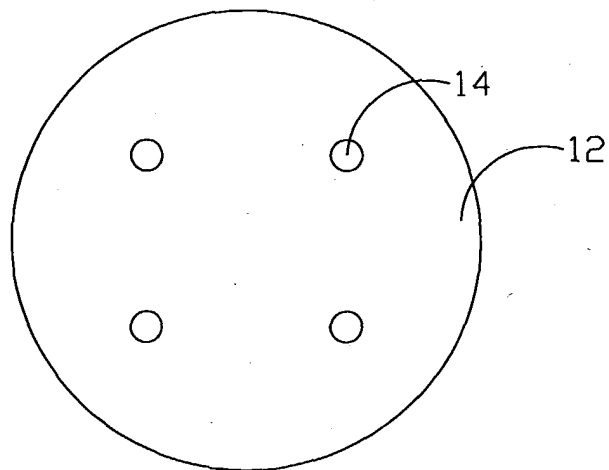


FIG. 1B(Prior Art)

APPARATUS AND METHOD FOR DETECTING WAFER POSITION

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Docket No. 4425-308

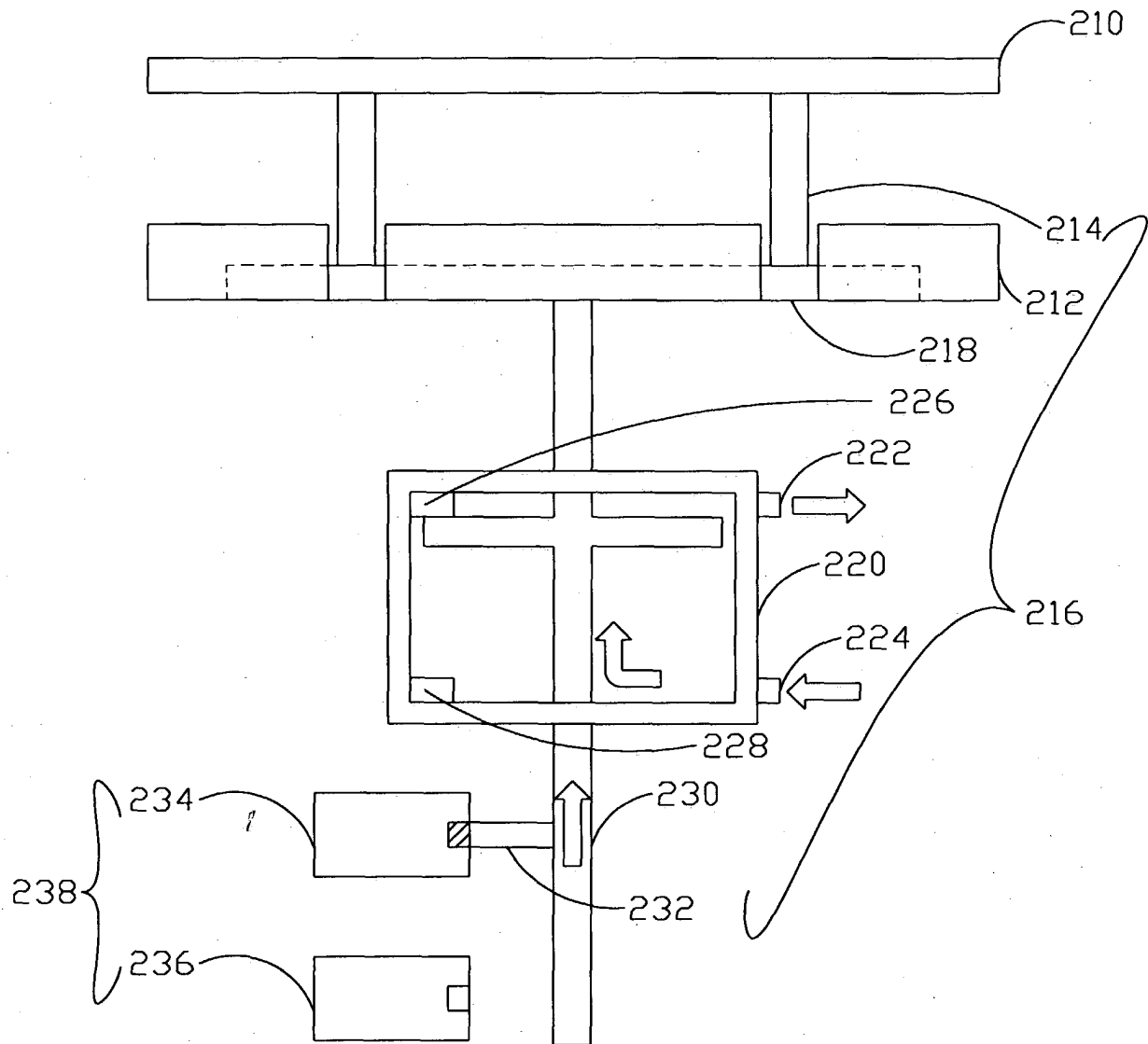


FIG.2A(Prior Art)

APPARATUS AND METHOD FOR DETECTING WAFER POSITION

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Docket No. 4425-308

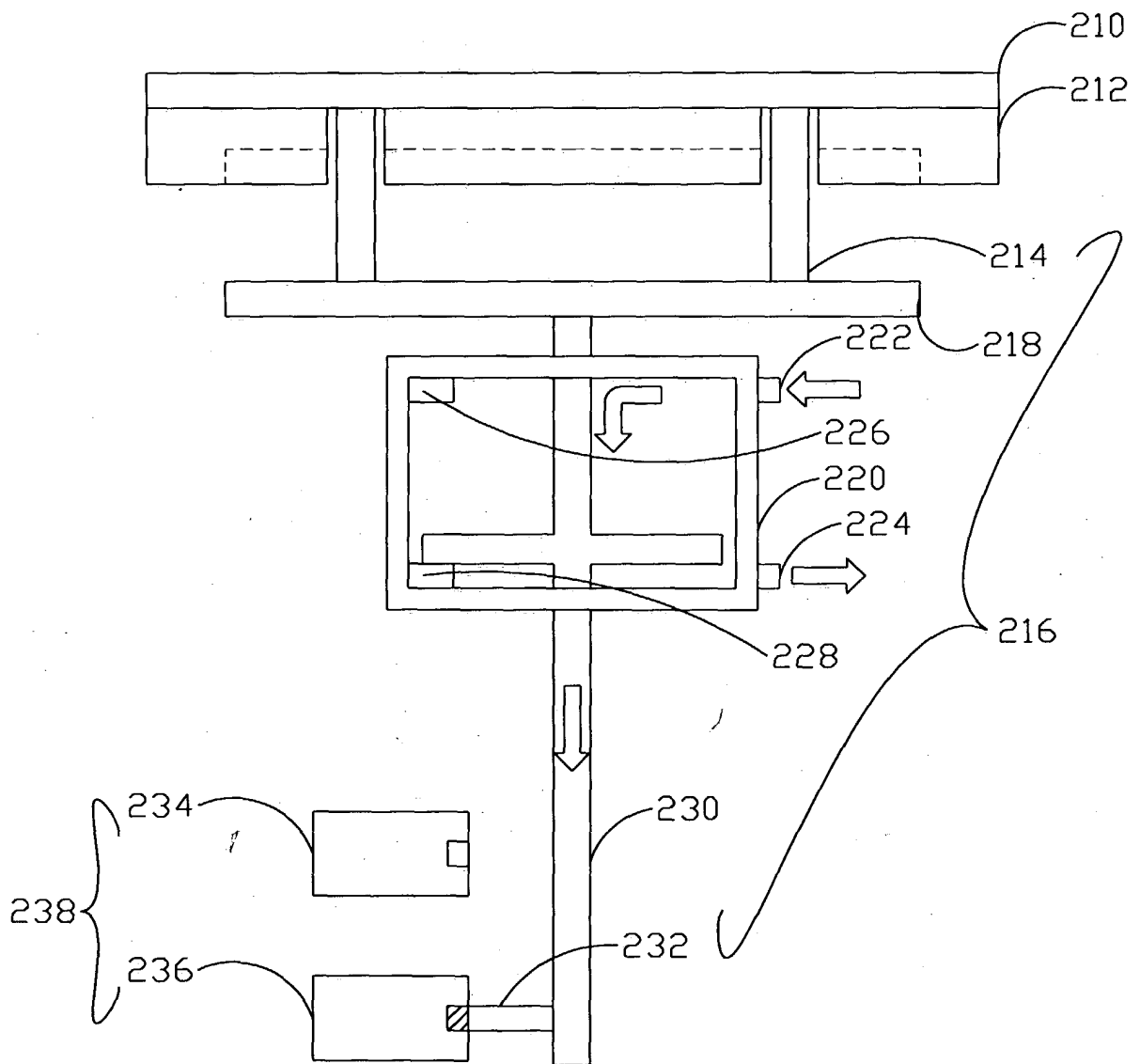


FIG.2B(Prior Art)

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Docket No. 4425-308

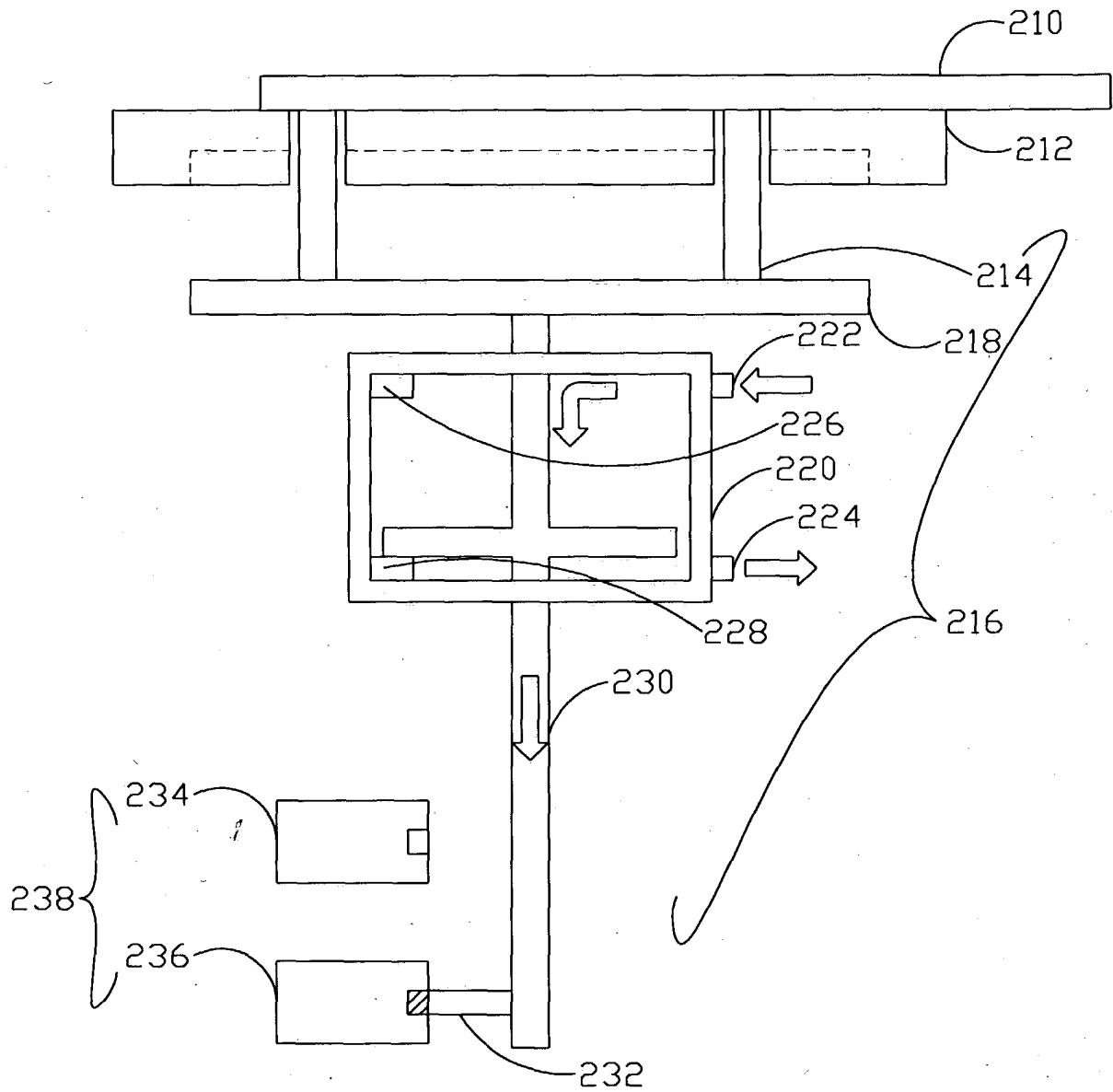


FIG.2C(Prior Art)

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Docket No. 4425-308

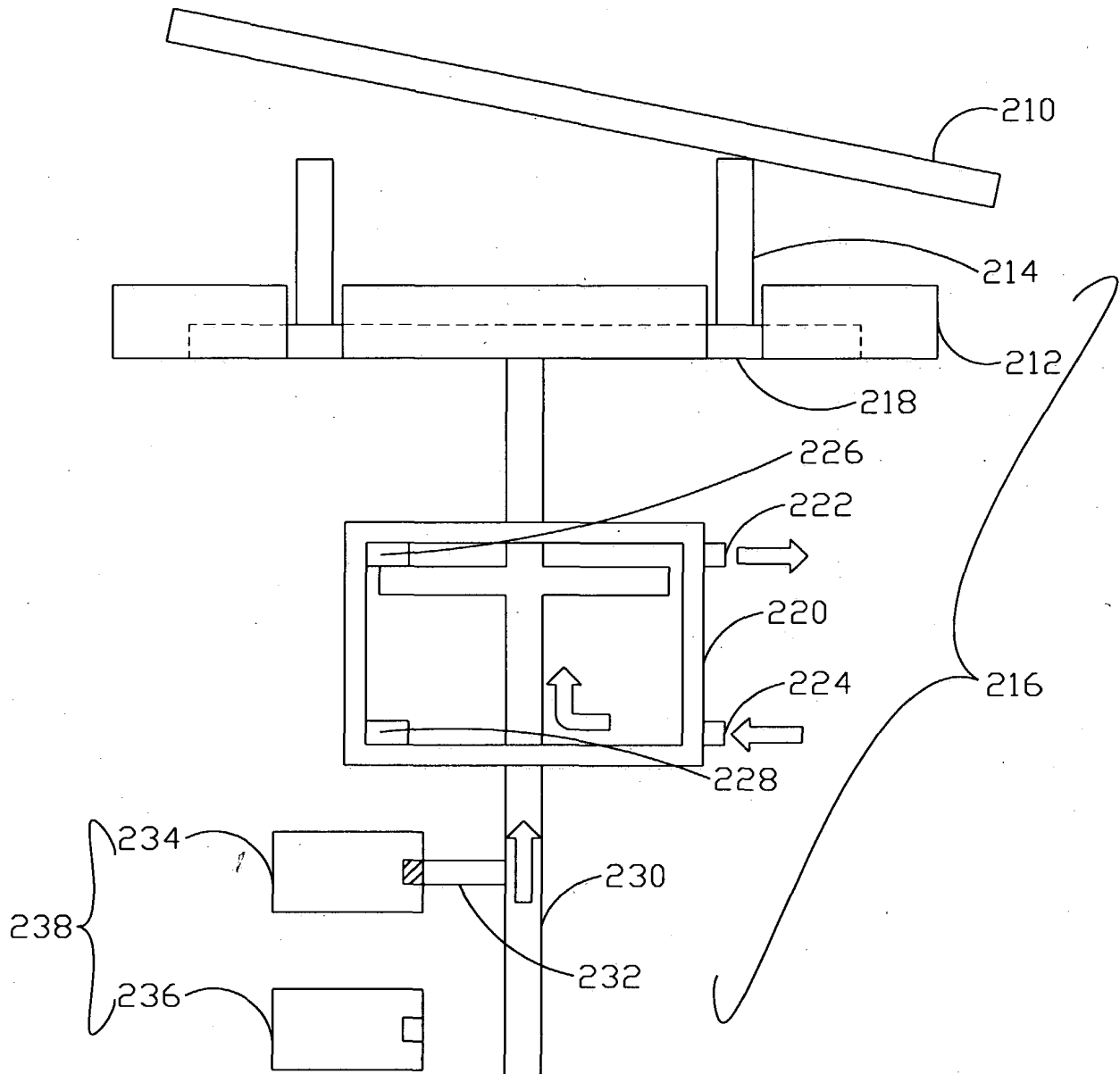


FIG.2D(Prior Art)

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Docket No. 4425-308

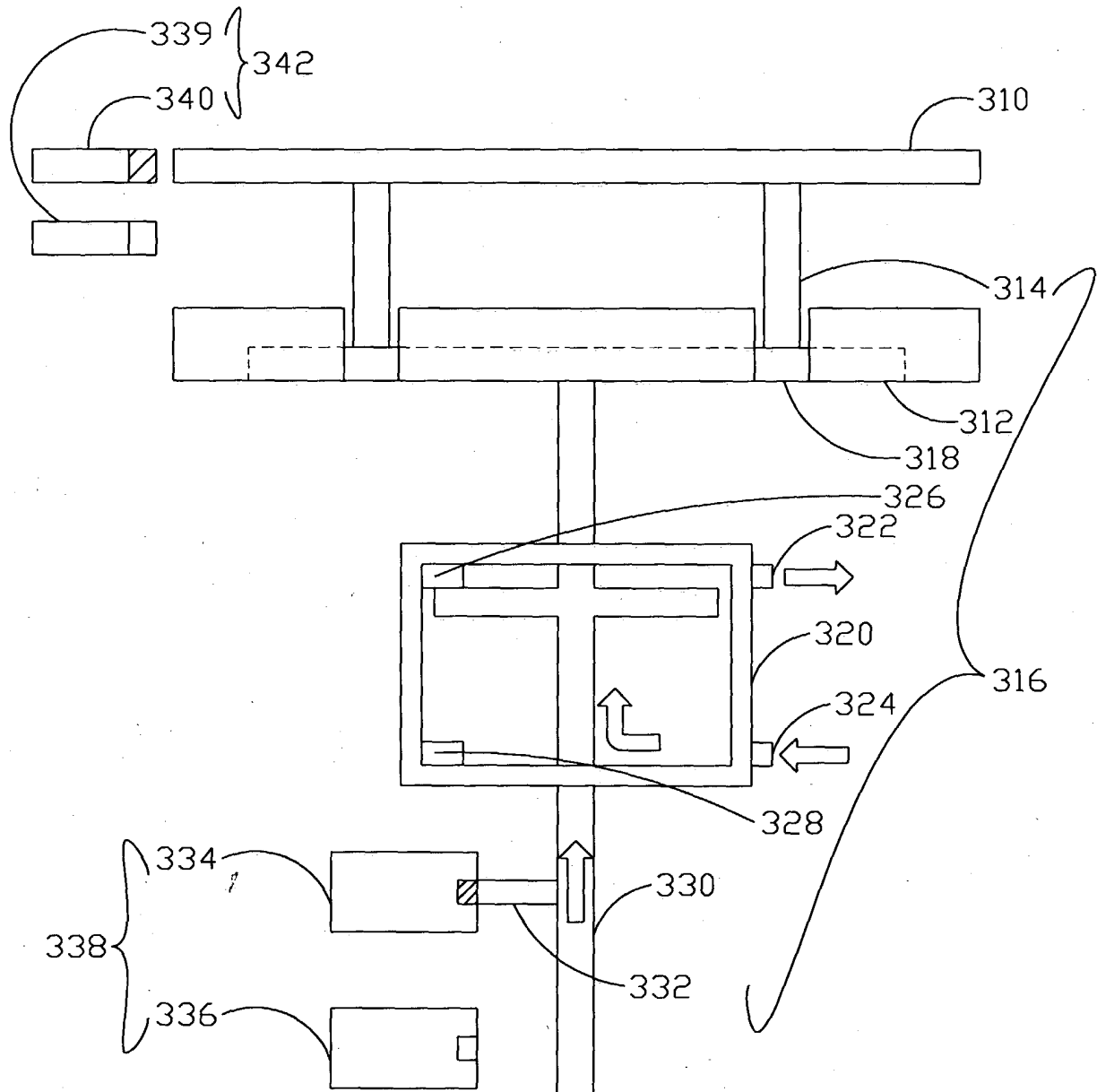


FIG.3A

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Docket No. 4425-308

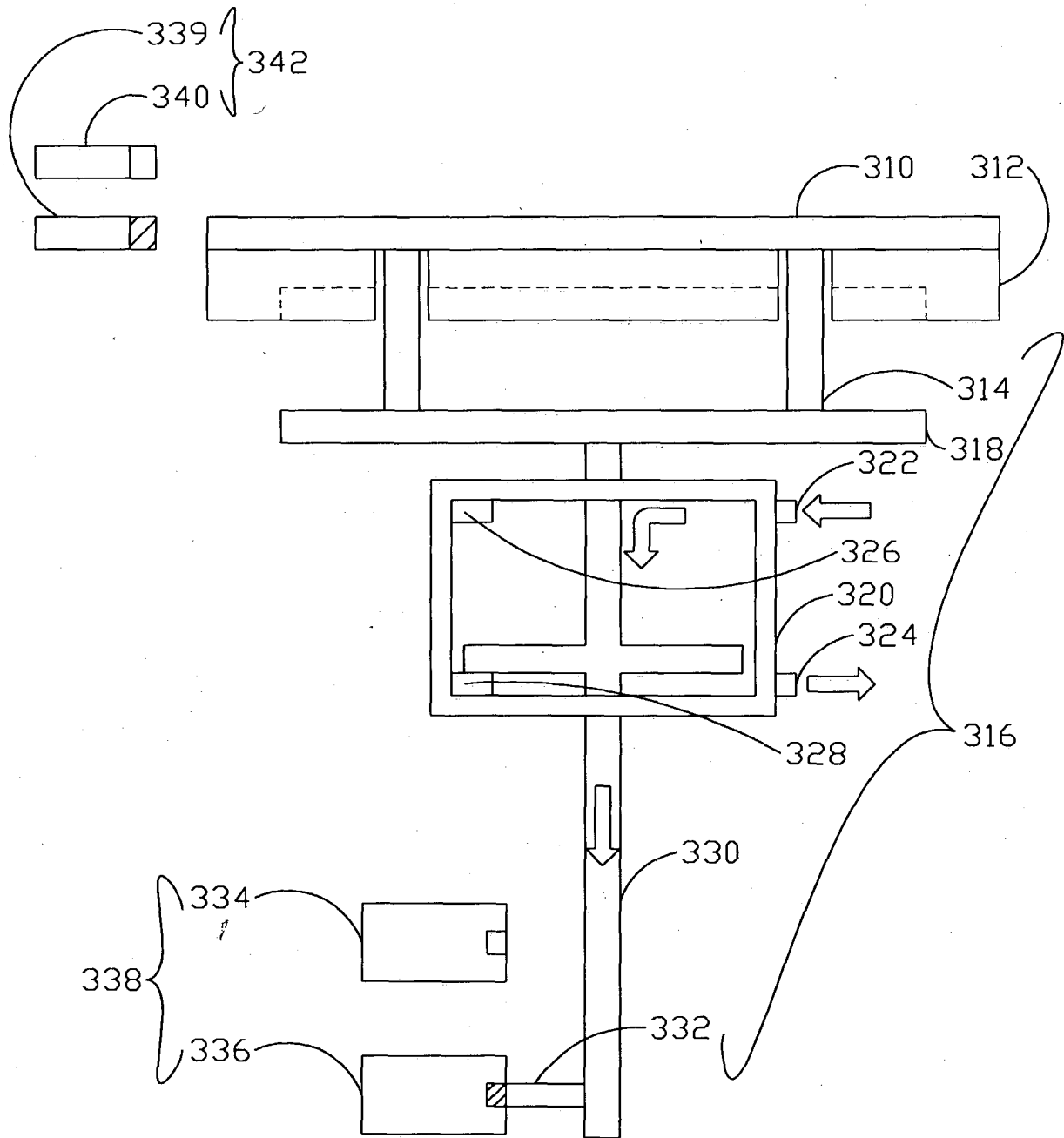


FIG.3B

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Docket No. 4425-308

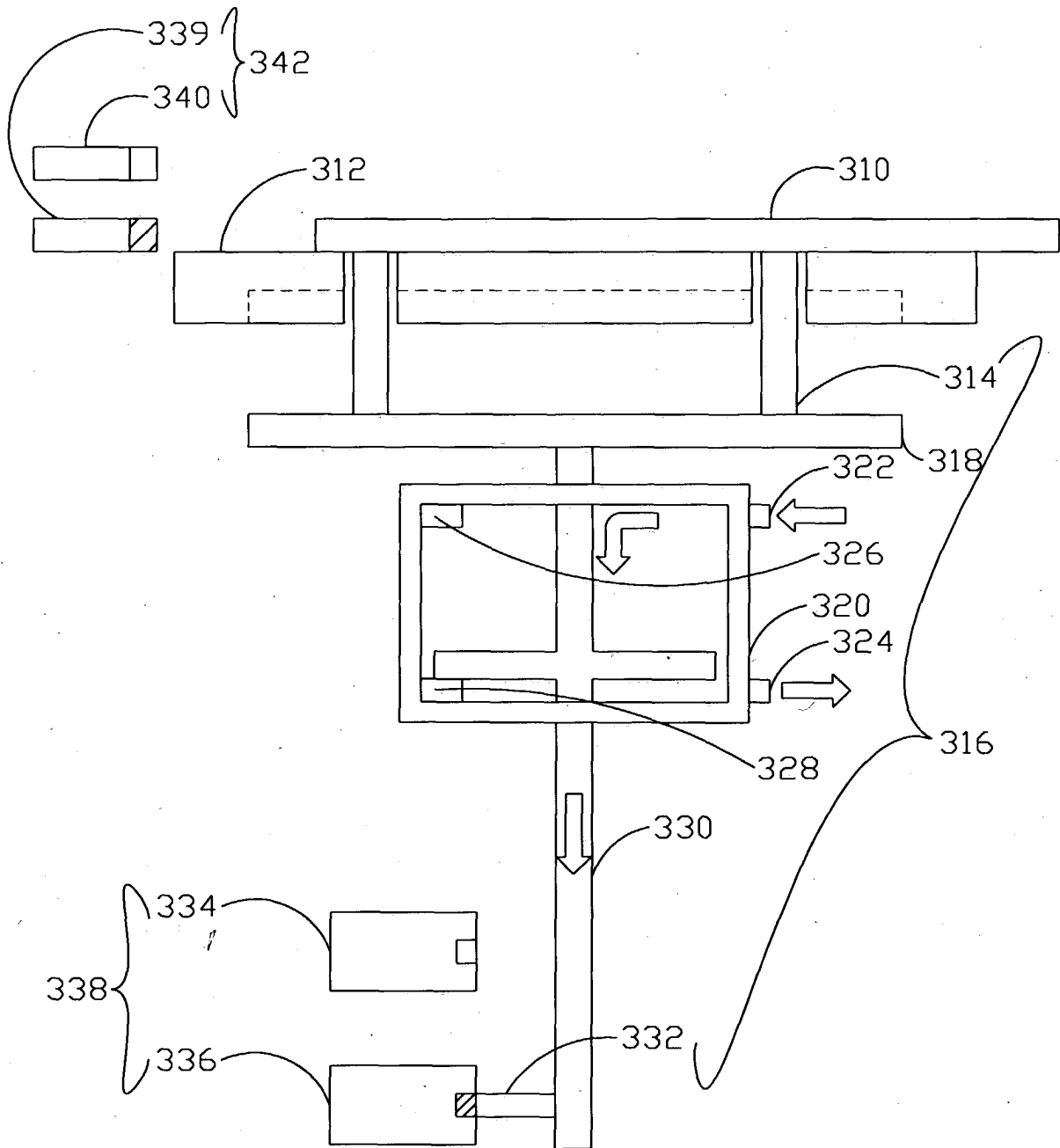


FIG.3C

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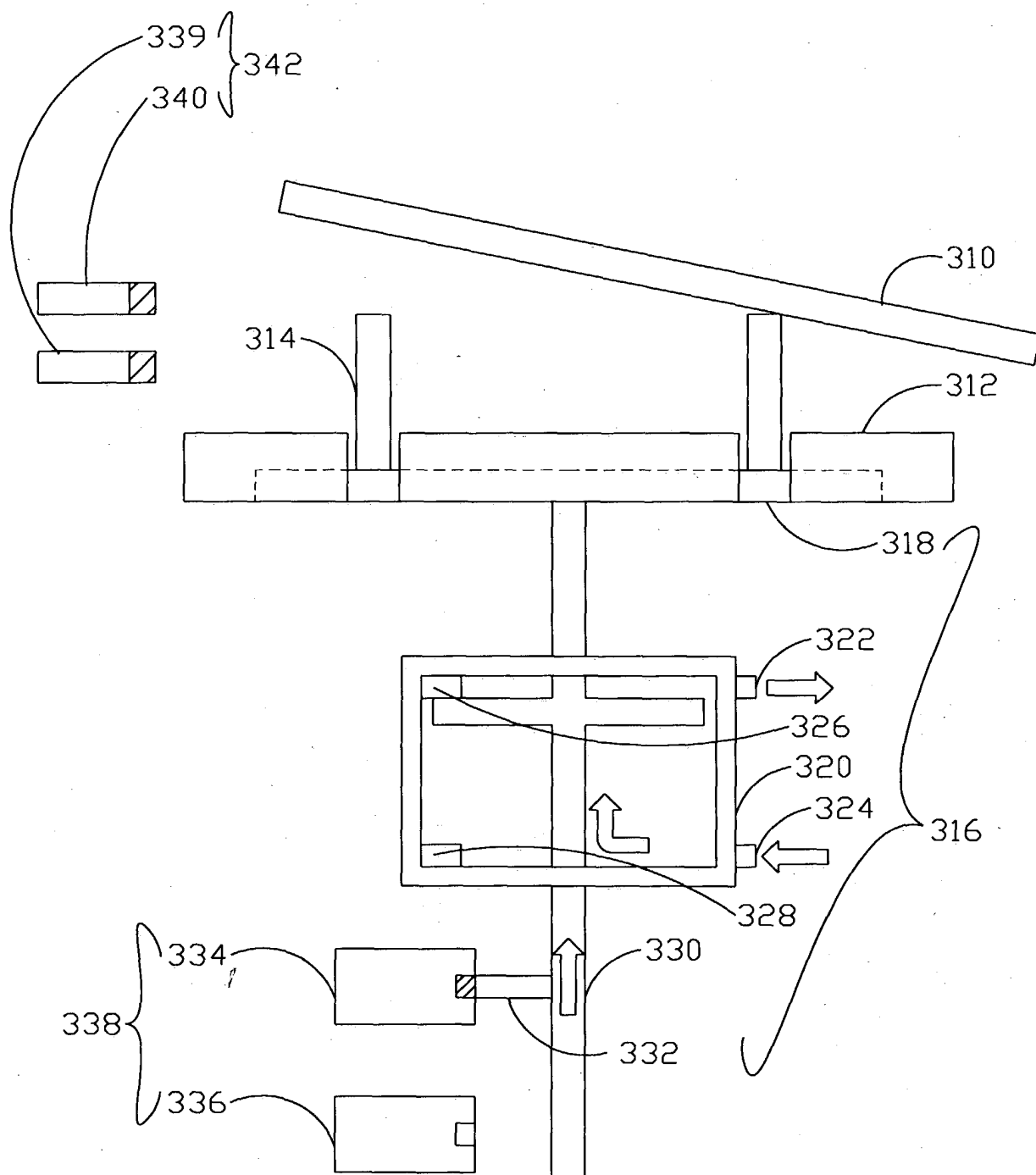


FIG. 3D

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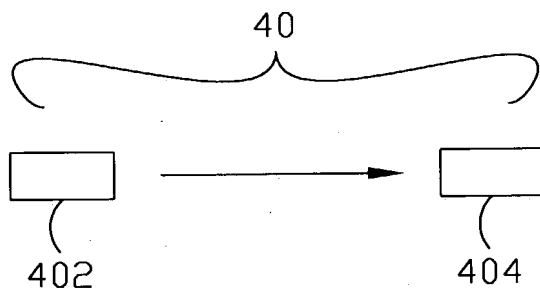


FIG. 4A

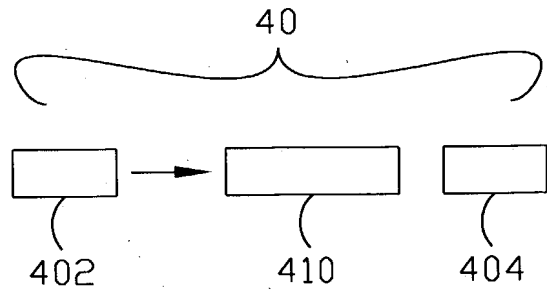


FIG. 4B

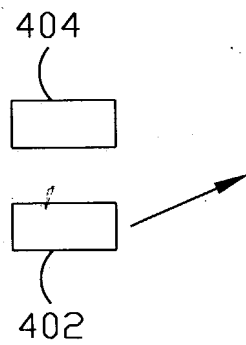


FIG. 4C

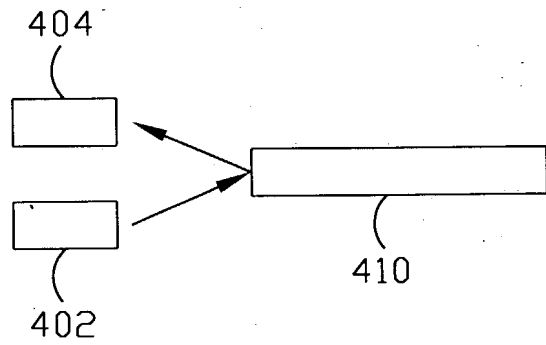


FIG. 4D

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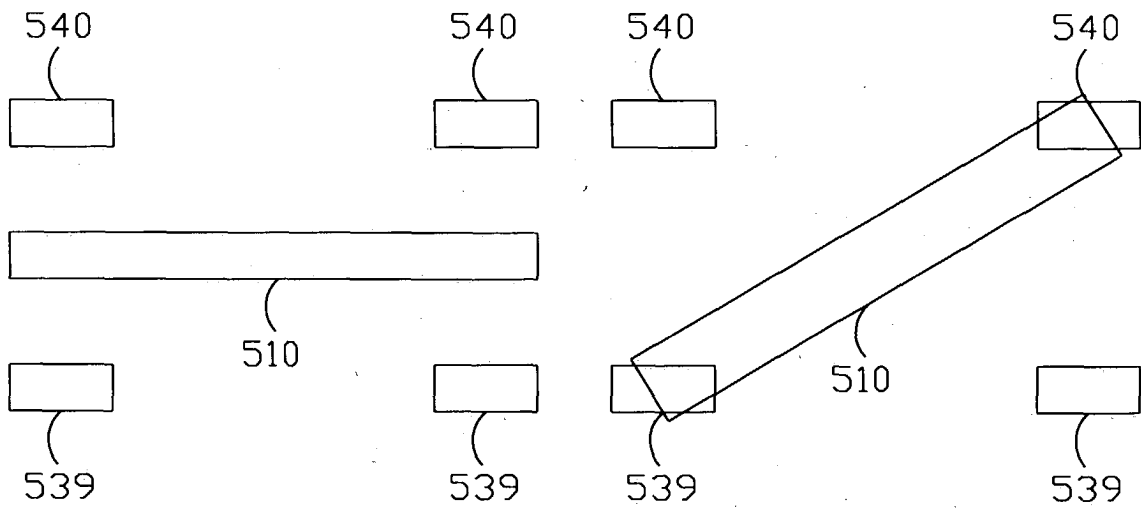


FIG. 5A

FIG. 5B

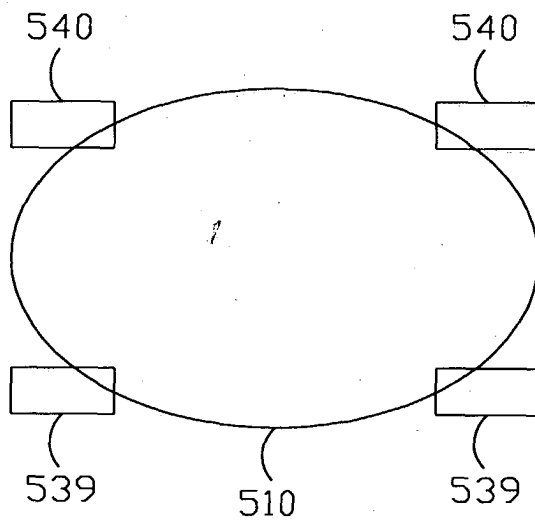


FIG. 5C